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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/730,358	12/09/2003	Satofumi Kinei	900-484	1789	
23117 7	590 09/02/2005		EXAMINER		
NIXON & VANDERHYE, PC 901 NORTH GLEBE ROAD, 11TH FLOOR			MOORE, KARLA A		
ARLINGTON,		IH FLOOK	ART UNIT	PAPER NUMBER	
			1763	· · · · · · · · · · · · · · · · · · ·	
			DATE MAILED: 00/02/2009	DATE MAILED: 09/02/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Application No.	Applicant(s)				
Office Action Commons	10/730,358	KINEI, SATOFUMI				
Office Action Summary	Examiner	Art Unit				
	Karla Moore	1763				
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply						
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.1 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply If NO period for reply is specified above, the maximum statutory period of Failure to reply within the set or extended period for reply will, by statute Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	36(a). In no event, however, may a reply be time within the statutory minimum of thirty (30) days will apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONE	nely filed s will be considered timely. the mailing date of this communication. D (35 U.S.C. § 133).				
Status						
1) Responsive to communication(s) filed on <u>31 May 2005</u> .						
2a) ☐ This action is FINAL . 2b) ☑ This	action is non-final.					
3) Since this application is in condition for alloward	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under E	Ex parte Quayle, 1935 C.D. 11, 45	53 O.G. 213.				
Disposition of Claims						
4) Claim(s) <u>1-8</u> is/are pending in the application.						
4a) Of the above claim(s) <u>8</u> is/are withdrawn from consideration.						
5) Claim(s) is/are allowed.						
6)⊠ Claim(s) <u>1-7</u> is/are rejected. 7)□ Claim(s) is/are objected to.						
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	r ciocion roquiromoni.					
Application Papers		•				
9) The specification is objected to by the Examiner.						
10) ☐ The drawing(s) filed on <u>09 December 2003</u> is/are: a) ☐ accepted or b) ☐ objected to by the Examiner. Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).						
	• • • • • • • • • • • • • • • • • • • •	` '				
Replacement drawing sheet(s) including the correct 11) The oath or declaration is objected to by the Ex						
		Action of 10/1/17 10-102.				
Priority under 35 U.S.C. § 119						
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority document application from the International Bureau * See the attached detailed Office action for a list	s have been received. s have been received in Applicati rity documents have been receive u (PCT Rule 17.2(a)).	on Noed in this National Stage				

3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 1203.

1) Notice of References Cited (PTO-892)

2) Notice of Draftsperson's Patent Drawing Review (PTO-948)

Attachment(s)

6) Other: _

4) Interview Summary (PTO-413)
Paper No(s)/Mail Date. _____.

5) Notice of Informal Patent Application (PTO-152)



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DETAILED ACTION

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Election/Restrictions

Claim 8 is withdrawn from further consideration pursuant to 37 CFR 1.142(b) as being drawn to a
nonelected invention (Group II), there being no allowable generic or linking claim. Election was made
without traverse in the reply filed on 31 May 2005.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1-2 and 4 are rejected under 35 U.S.C. 103(a) as being unpatentable over U.S. Patent No. 4,543,576 to Hieber et al. in view of U.S. Patent No. 4,975,252 to Nishizawa et al.
- 4. Heiber et al. disclose a semiconductor device production apparatus substantially as claimed in Figures 1-5 and comprising: a rotary table section (7, abstract) including a rotary table for supporting a wafer (1) thereon; a chamber (22) for housing the rotary table section; a heater (abstract and column 3, rows 67-68) for heating the wafer; a temperature sensing device (14 and 15) for sensing the temperature of the wafer; temperature measuring section (25) for converting the sensed temperature into a first signal to output the first signal; and a signal generating section (26) for converting the output first signal into a second signal detectable from outside the chamber (via transmitter 27); wherein the temperature sensing device, the temperature measuring section and the signal generating section are attached to the rotary table section (each is arranged in measuring system, 18, attached to pallet 7).
- 5. However, Heiber fail et al. fail to explicitly teach the heater provided in the chamber.

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6. Nishizawa et al. teach that it is known in the art to provide a substrate heater structures inside or outside a processing chamber during a deposition process (column 6, rows 40-46 and column 8, rows 15-22).

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- 7. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided the substrate heater either inside or outside the deposition chamber in Heiber et al. as is known in the art as taught by Nishizawa et al.
- 8. With respect to claim 2, Heiber et al. fail to teach the temperature sensing device includes a thermocouple.
- 9. Nishizawa et al. disclose the use of thermocouple for measuring the temperature of a substrate during processing (column 4, rows 29-32).
- 10. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided a thermocouple as the temperature sensing device in Heiber et al. in order to measure the temperature of the substrate as taught by Nishizawa et al.
- 11. With respect to claim 4, as noted above, the signal generating section comprises a wireless transmitter (27).
- 12. Claim 3 is rejected under 35 U.S.C. 103(a) as being unpatentable over Hieber et al. and Nishizawa et al. as applied to claims 1-2 and 4, and further in view of U.S. Patent Pub. No. 2003/0168171 A1 to Tanaka et al.
- 13. Heiber et al. and Nishizawa et al. disclose the invention substantially as claimed and as described above.
- 14. However, Heiber et al. and Nishizawa et al. fail to teach the signal generating section comprises a detachable storage device.
- 15. Tanaka et al. teach the use of a detachable storage device in processing data associated with semiconductor manufacturing processes for the purpose of advantageously reducing the load on a data collecting device and for easily controlling collected data (paragraphs 44-48).

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16. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided the signal generating section comprising a detachable storage device in Hieber et al. and Nishizawa et al. in order to advantageously reduce the load on the data collecting device and easily control collected data as taught by Tanaka et al.

- 17. Claim 5 is rejected under 35 U.S.C. 103(a) as being unpatentable over Hieber et al. and Nishizawa et al. as applied to claims 1-2 and 4, and further in view of U.S. Patent No. 4,683,143 to Riley.
- 18. Heiber et al. and Nishizawa et al. disclose the invention substantially as claimed and as described above.
- 19. However, Heiber et al. and Nishizawa et al. fail to teach the signal generating section comprises a display device.
- 20. Riley teach the use of a display device for displaying processing conditions for the purpose of periodically updating a user regarding the status of a process while controlling a process (column row row 57, through column 2, row 5).
- 21. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided a display device in Heiber et al. and Nishizawa et al. in order to periodically update a user regarding the status of a process while controlling the process as taught by Riley.
- 22. Claim 6 is rejected under 35 U.S.C. 103(a) as being unpatentable over Hieber et al., Nishizawa et al. and Tanaka et al. as applied to claim 3, and further in view of U.S. Patent No. 4,683,143 to Riley.
- 23. Heiber et al., Nishizawa et al. and Tanaka disclose the invention substantially as claimed and as described above.
- 24. However, while Heiber et al. do disclose the use of a computer/storage data reader (30) for accepting measured data from the apparatus, wherein the computer is located outside the chamber; Heiber et al., Nishizawa et al. and Tanaka et al. fail to explicitly teach the apparatus further comprises a heater controlling section, also provided outside the chamber.

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25. Riley discloses the use of a heater controller located outside a processing chamber for the purpose of controlling internal heaters used to regulate temperature of a processing apparatus (column 3, rows 47-56).

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- 26. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided a heater controller in Heiber et al., Nishizawa et al. and Tanaka et al. in order to control internal heaters used to regulate temperatures of the processing apparatus as taught by Riley.
- 27. Claim 7 is rejected under 35 U.S.C. 103(a) as being unpatentable over Hieber et al. and Nishizawa et al. as applied to claims 1-2 and 4, and further in view of U.S. Patent No. 4,683,143 to Riley.
- Heiber et al. and Nishizawa et al. disclose the invention substantially as claimed and as described ·28. above.
- 29. However, while Heiber et al. do disclose a receiver (29) for receiving the wireless signal form the transmitter, wherein the receiver is located outside the chamber; Heiber et al. and Nishizawa et al. fail to explicitly teach the apparatus further comprises a heater controlling section, also provided outside the chamber.
- 30. Riley discloses the use of a heater controller located outside a processing chamber for the purpose of controlling internal heaters used to regulate temperature of a processing apparatus (column 3, rows 47-56).
- 31. It would have been obvious to one of ordinary skill in the art at the time the Applicant's invention was made to have provided a heater controller in Heiber et al. and Nishizawa et al. in order to control internal heaters used to regulate temperatures of the processing apparatus as taught by Riley.

Conclusion

32. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure. USP 4975252; 5147498; 5549756; 5969639; 6328802; 20020148307; 6827630; 6895831; 6907364 and 20040007326 each disclose temperature control mechanisms for a processing chamber.

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Any inquiry concerning this communication or earlier communications from the examiner should

be directed to Karla Moore whose telephone number is 571.272.1440. The examiner can normally be

reached on Monday-Friday, 9:00 am-6:00 pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor,

Parviz Hassanzadeh can be reached on 571.272.1435. The fax phone number for the organization

where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application

Information Retrieval (PAIR) system. Status information for published applications may be obtained from

either Private PAIR or Public PAIR. Status information for unpublished applications is available through

Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should

you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC)

at 866-217-9197 (toll-free).

Karla Moore Patent Examiner Art Unit 1763

22 August 2005